



Pixel2000



A MEASUREMENT OF LORENTZ ANGLE OF RAD-HARD PIXEL SENSORS



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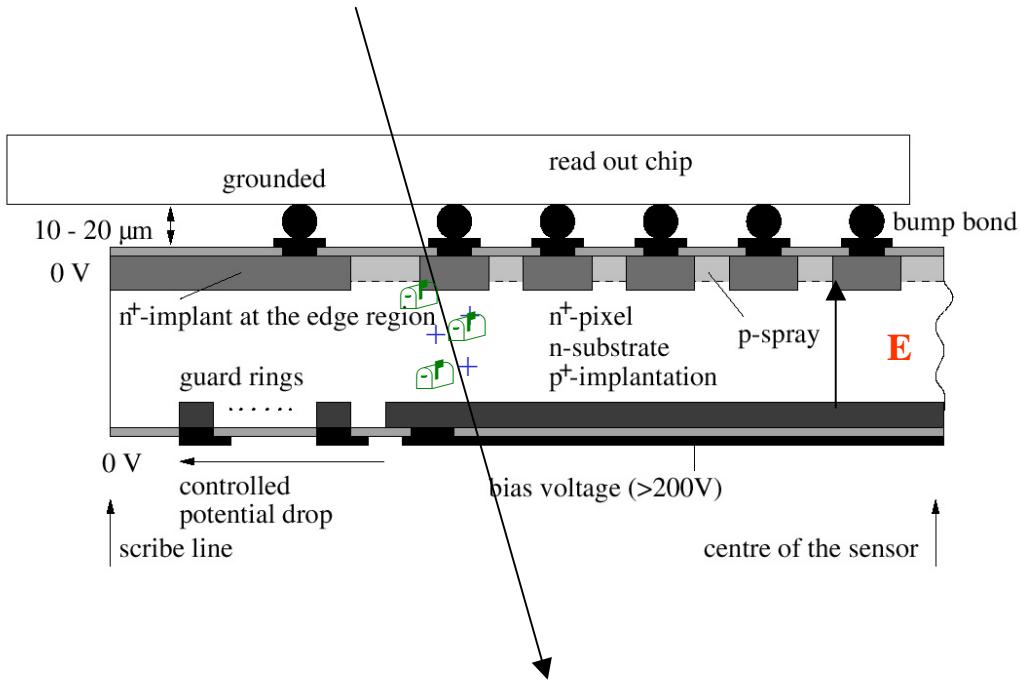
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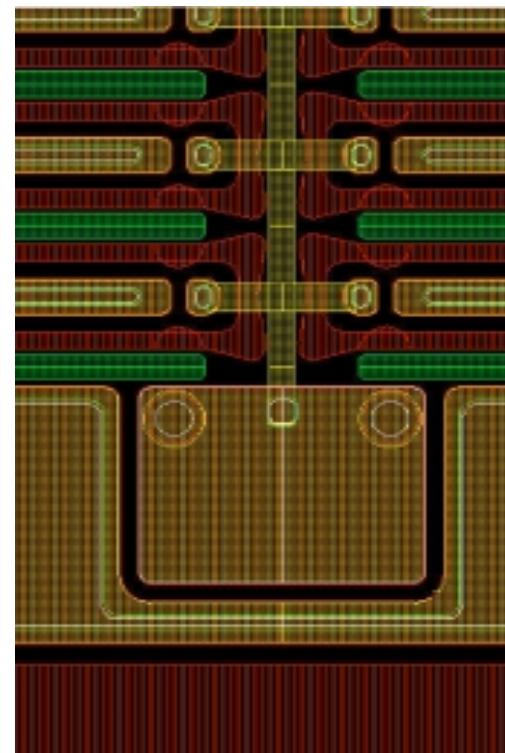


Every chip is a matrix of 18 columns and 160 rows

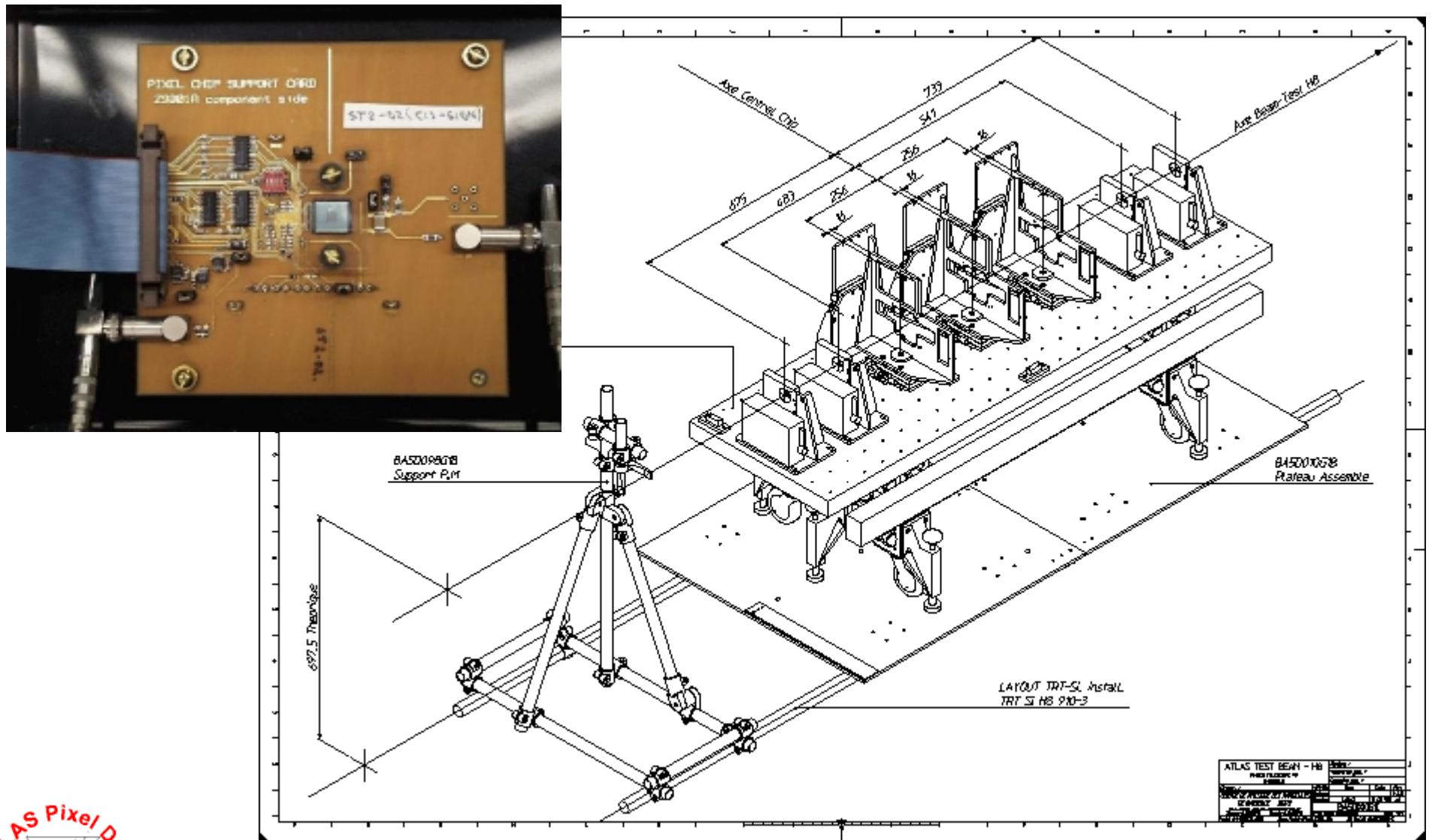
Pixel size is $50\text{ }\mu\text{m} \times 400\text{ }\mu\text{m}$

Thickness 280 μm

Test sensors are irradiated at a fluence of $5 \times 10^{14} \text{n}_{\text{eq}}/\text{cm}^2$ and $1 \times 10^{15} \text{n}_{\text{eq}}/\text{cm}^2$.



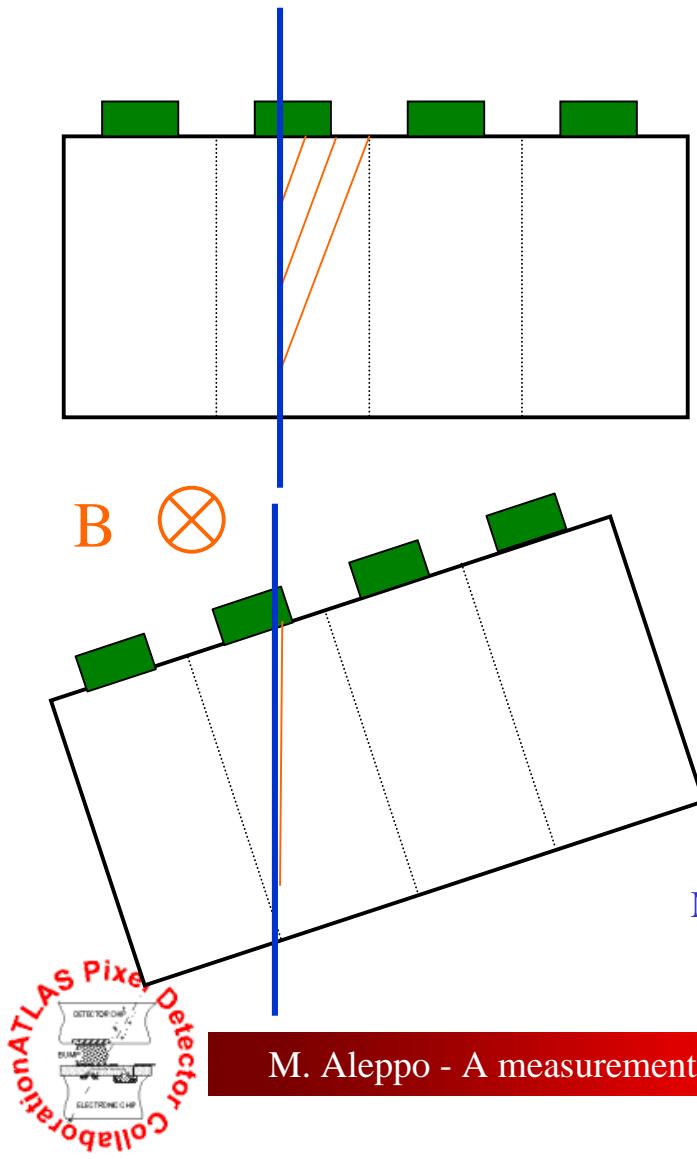
TEST BEAM SETUP



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THE IMPORTANCE OF THE LORENTZ ANGLE MEASUREMENT

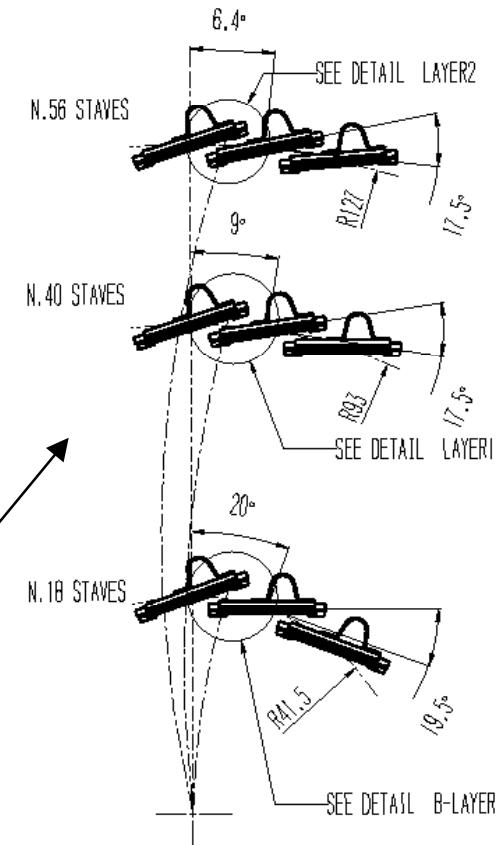
Charge drifts with an angle $\gamma_{\phi L}$ respect to the direction of the Electric field in presence of a Magnetic field



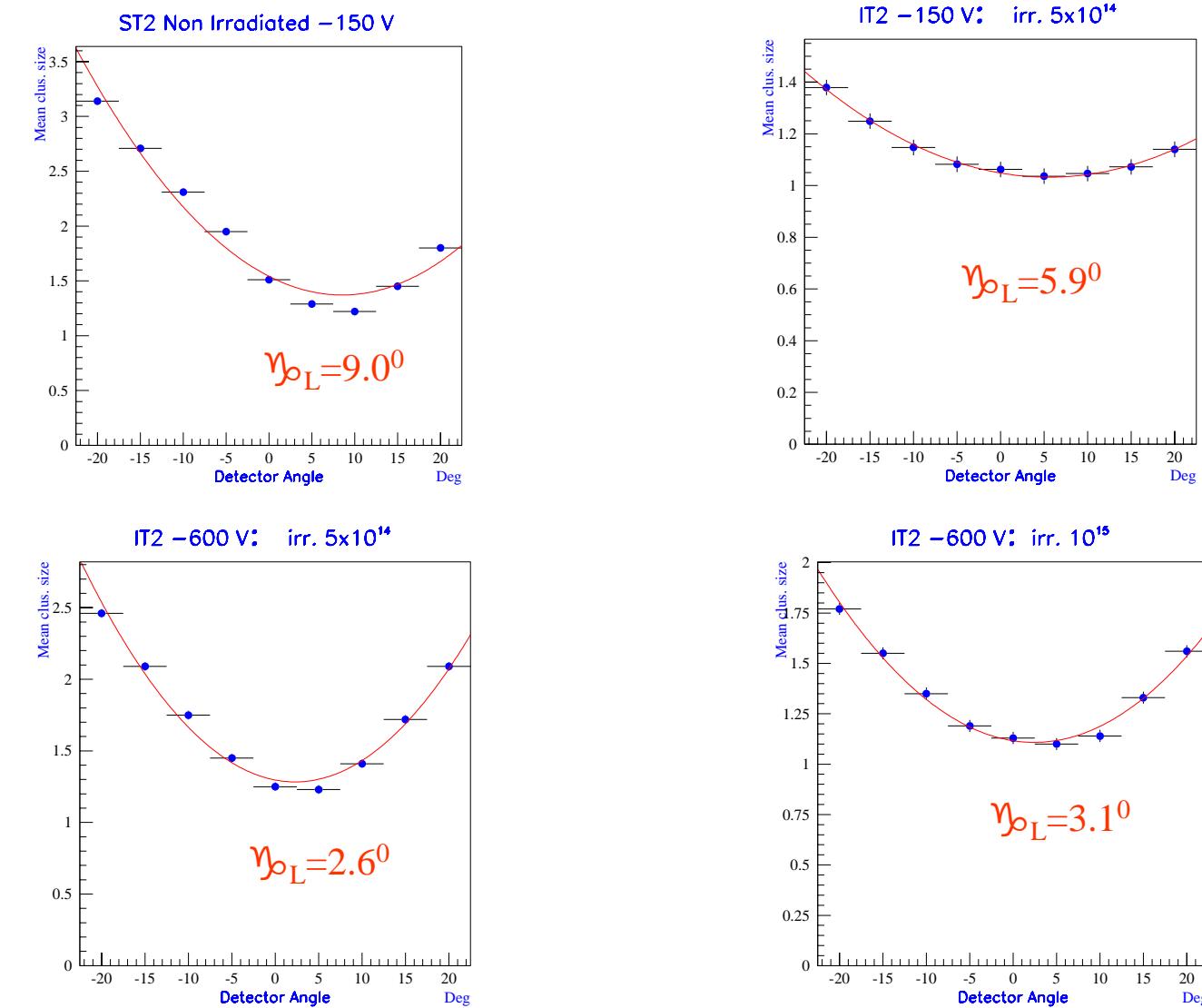
Charge sharing depends upon the Lorentz angle.

→ This affects detector performances: space resolution, efficiency and occupancy.

Modules are tilted to take into account the effect of Lorentz angle on the charge drift.



Measurement of the mean cluster size as a function of the angle



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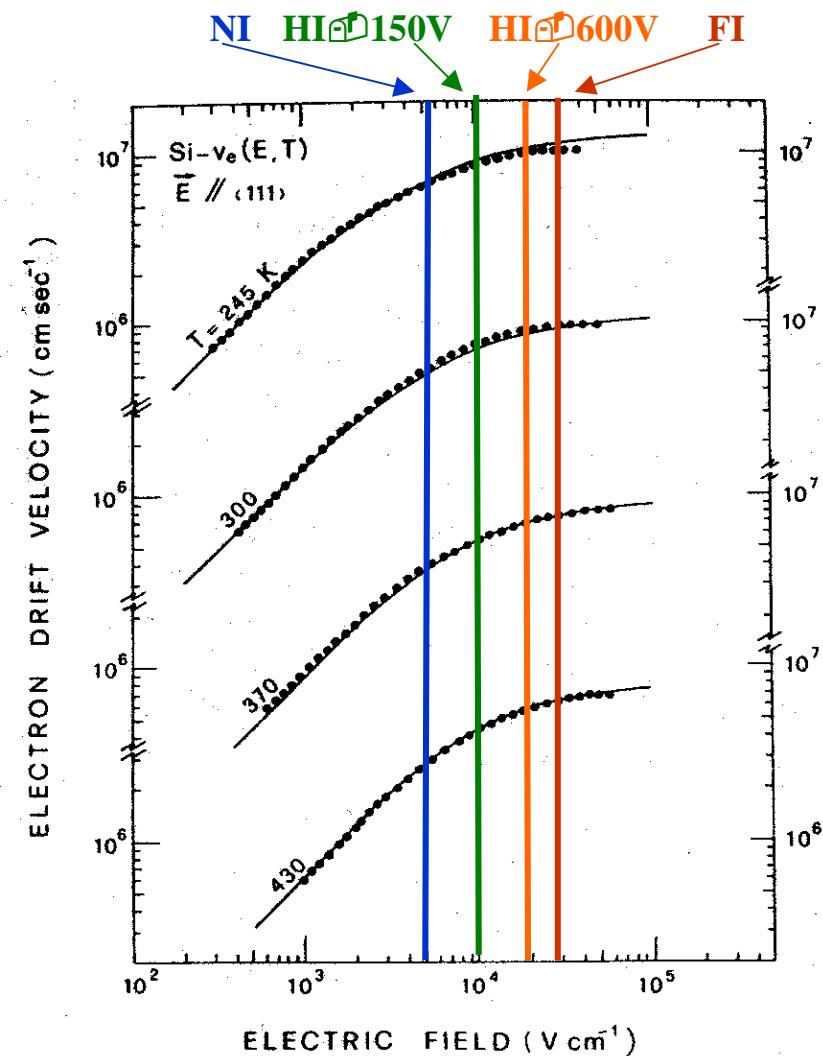
L O R E N T Z A N G L E M O D E L

$$\operatorname{tg}(\gamma_L) = r \cdot B \cdot \mu_d$$

$$r = \langle \tau^2 \rangle / \langle \tau \rangle^2$$

$$\mu_d = \frac{v_s/E_c}{[1 + (E/E_c)^\beta]^{1/\beta}}$$

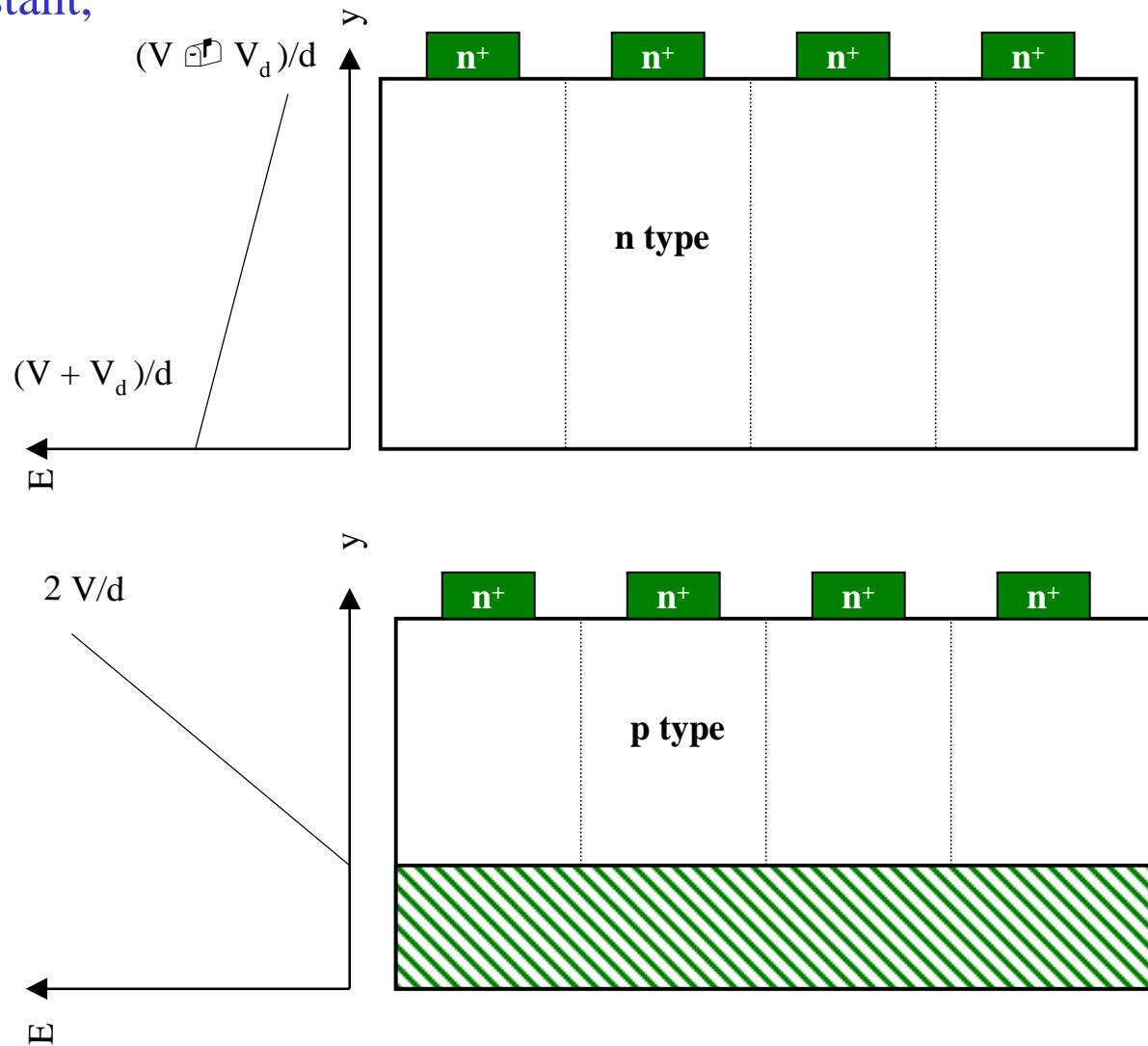
$$\begin{cases} v_s = 1.53 \cdot 10^9 \cdot T^{-0.87} \text{ cm s}^{-1} \\ E_c = 1.01 \cdot T^{1.55} \text{ V cm}^{-1} \\ \beta = 2.57 \cdot 10^{-2} \cdot T^{-0.66} \text{ cm s}^{-1} \end{cases}$$



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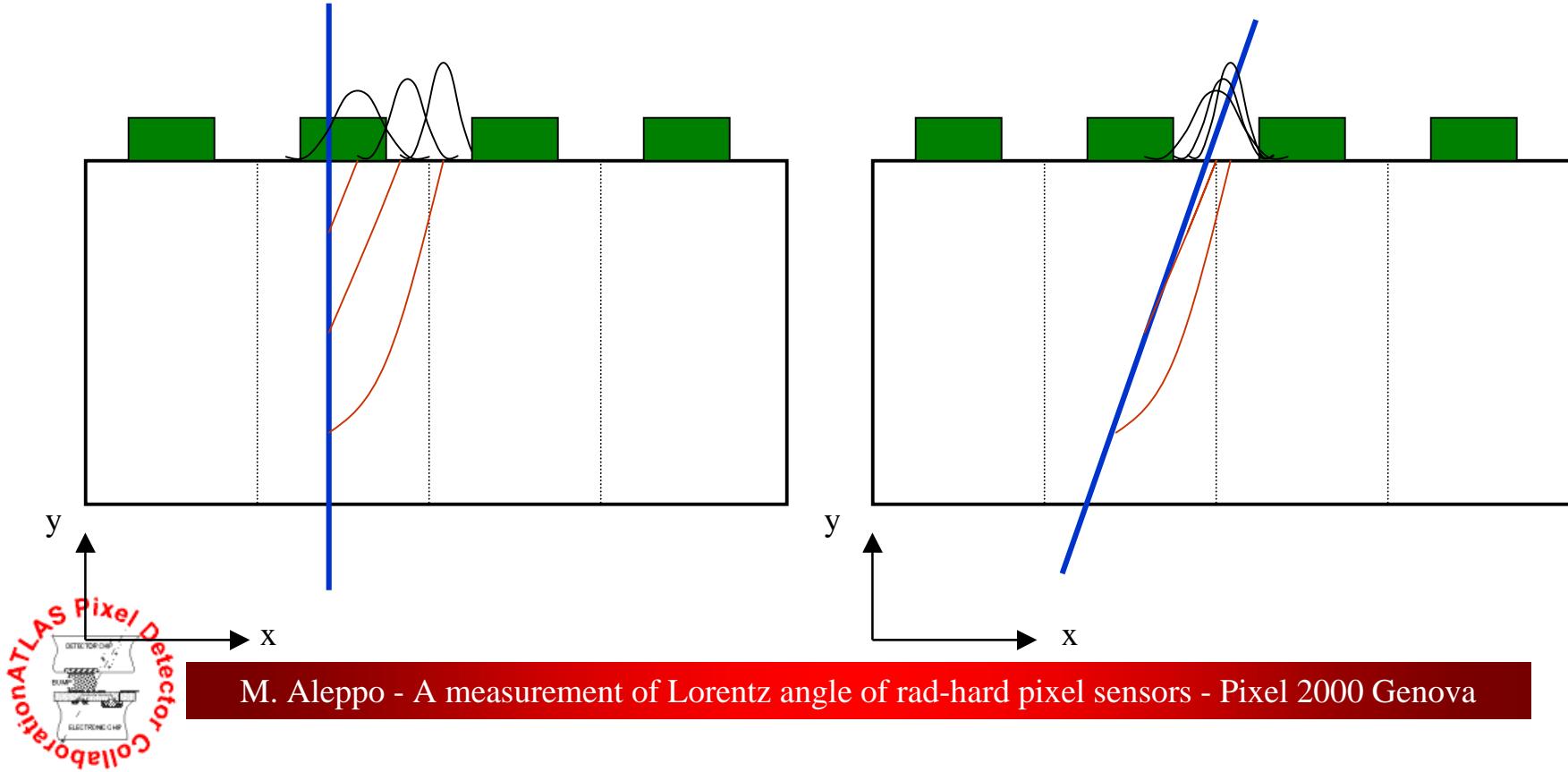
The Electric field is not constant,
due to the spatial charge.

The charge distribution
is assumed to be uniform.



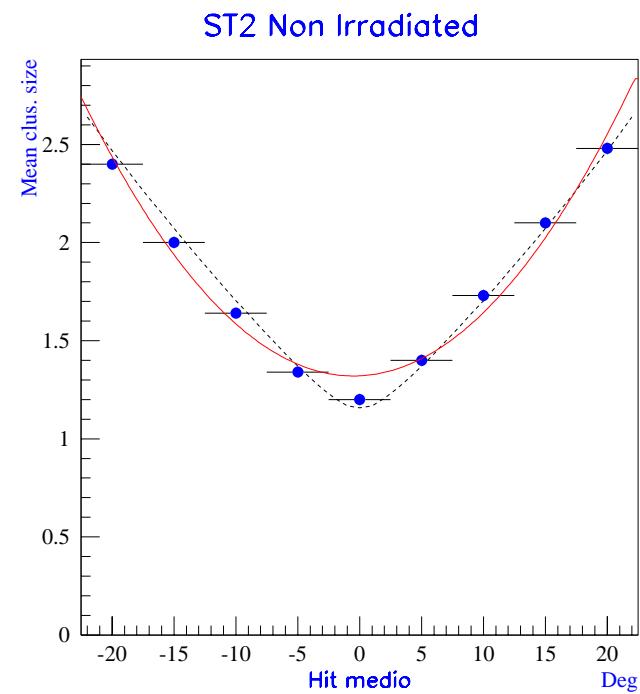
$$\tan(\gamma_L) = \frac{dx}{dy}(y) = r B \mu_d(E(y), T)$$

An effective Lorentz angle has been defined as the angle corresponding to the minimum cluster size.



LORENTZ ANGLE MEASUREMENT

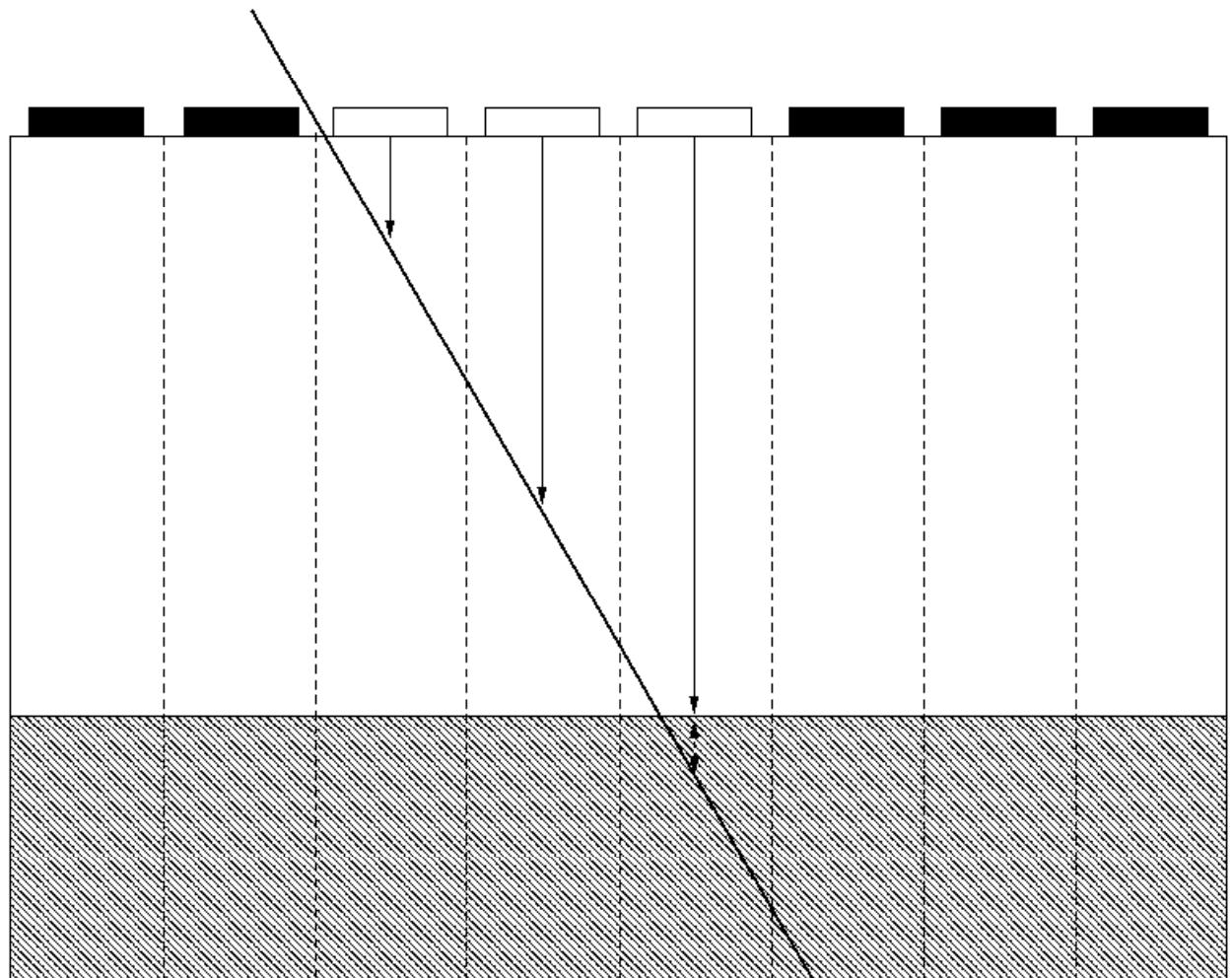
- Measured mean cluster size for different angles with B_{on} (1.4 Tesla) and B_{off}
- Data with B_{off} are used to check systematic effects
- Fits with a parabola
- Comparison with results obtained with the model:
 - Depletion taken from data
 - Threshold fitted from data taken with B_{off}



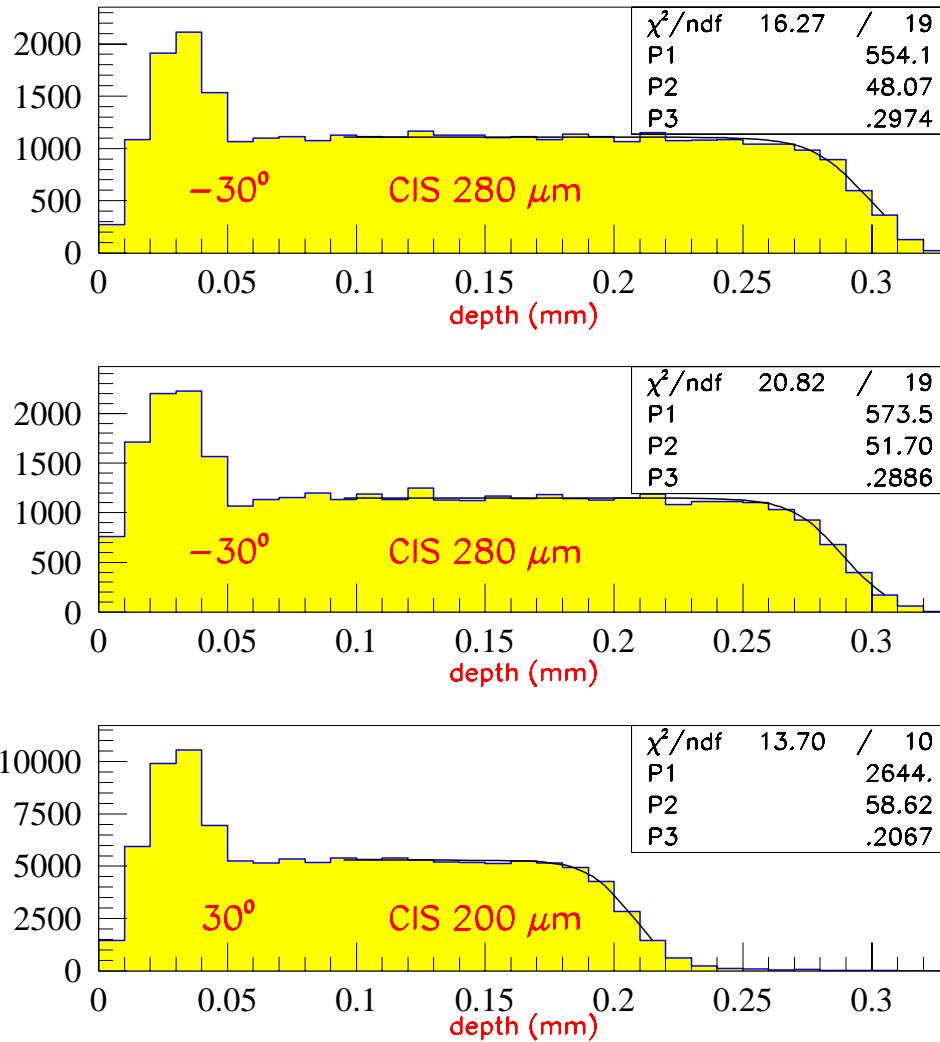
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DEPLETION DEPTH MEASUREMENT

- Performed rotating the sensor around the pixel axis parallel to the long size of pixels.
- Strategy based on the determination of the entrance and exit points of tracks
- Charge segment depth plots

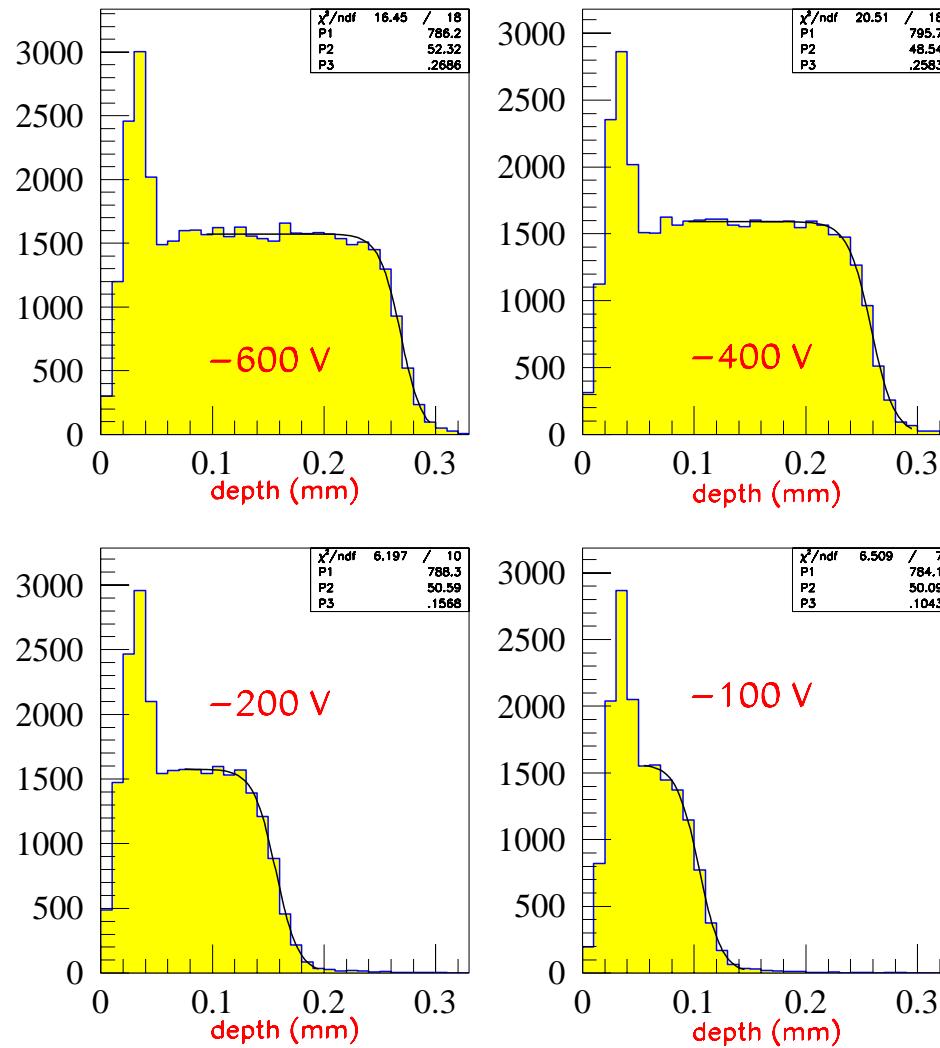


ST2 non irradiated



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IT2 at -30° irr. 5×10^{14}



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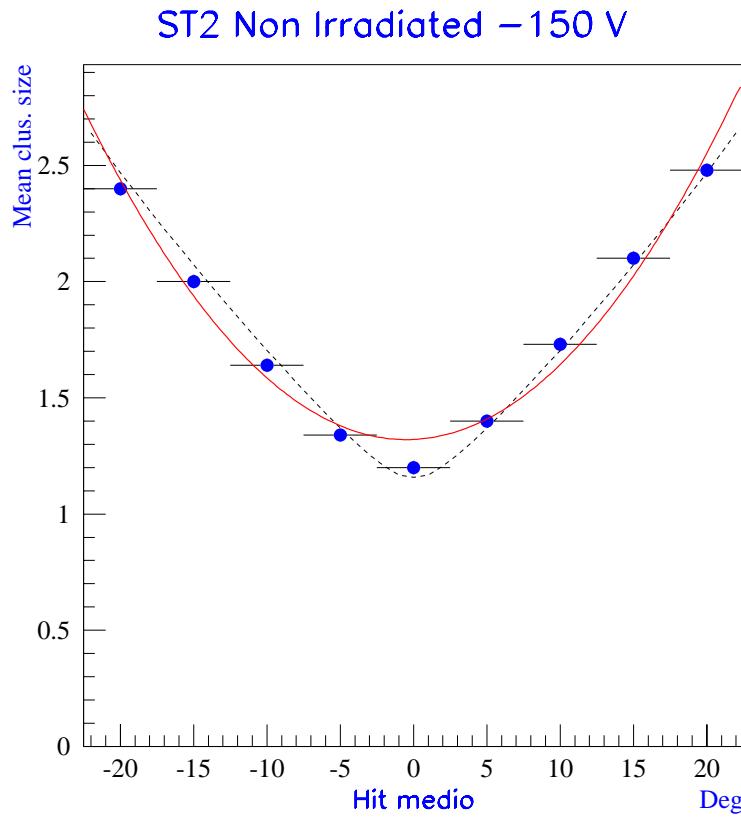
DEPLETION DEPTH RESULTS

Fluence	Thickness [μm]	Bias Voltage [V]	Angle [$^{\circ}$]	Depletion depth [μm]
0	280	150	-30	284 ± 7
0	280	150	+30	280 ± 10
0	200	150	+30	190 ± 7
5×10^{14}	280	600	-30	261 ± 8
5×10^{14}	280	400	-30	252 ± 10
5×10^{14}	280	200	-30	147 ± 7
5×10^{14}	280	150	-30	123 ± 11
5×10^{14}	280	100	-30	100 ± 7
10^{15}	280	600	-30	186 ± 14
10^{15}	280	600	+30	198 ± 24
10^{15}	280	300	-30	111 ± 10
10^{15}	280	600	-20	216 ± 16
10^{15}	280	600	+20	219 ± 22



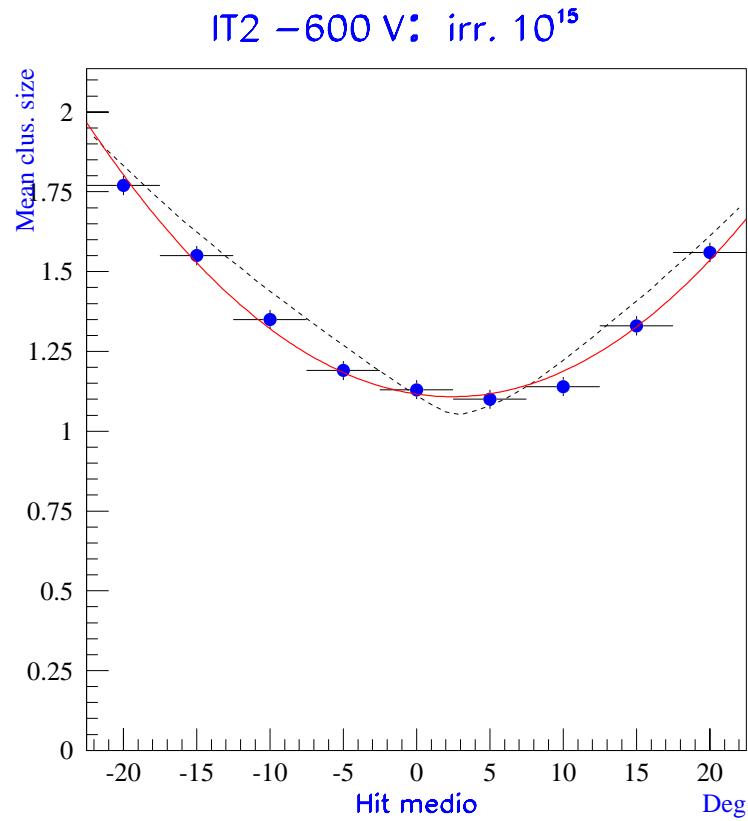
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L O R E N T Z A N G L E F I T S



Measured value $\gamma_{\text{O}} = 9.0^{\circ} \pm 0.4^{\circ} \pm 0.5^{\circ}$

Predicted value $\gamma_{\text{O}} = 8.6^{\circ} \pm 0.4^{\circ}$

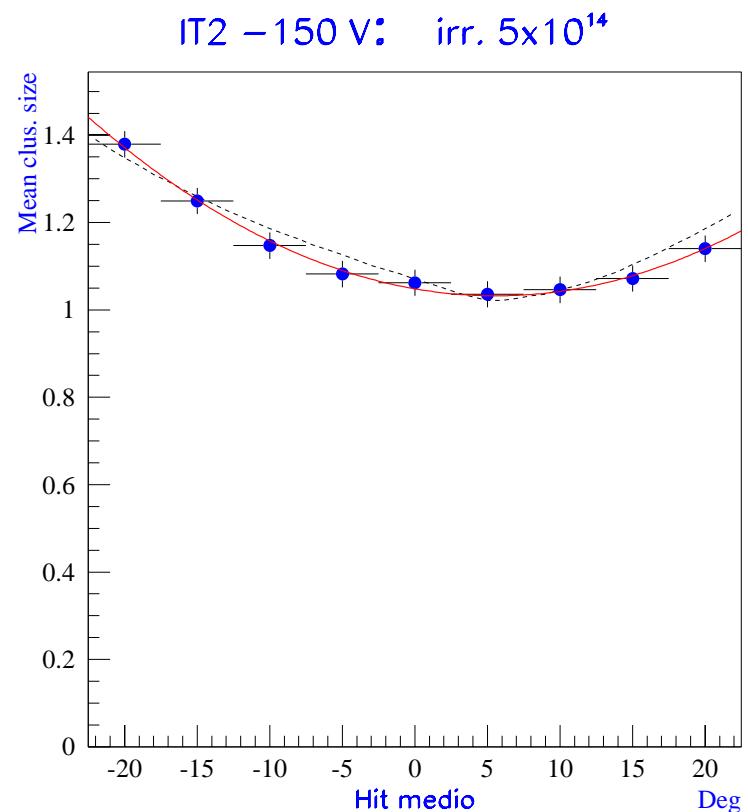
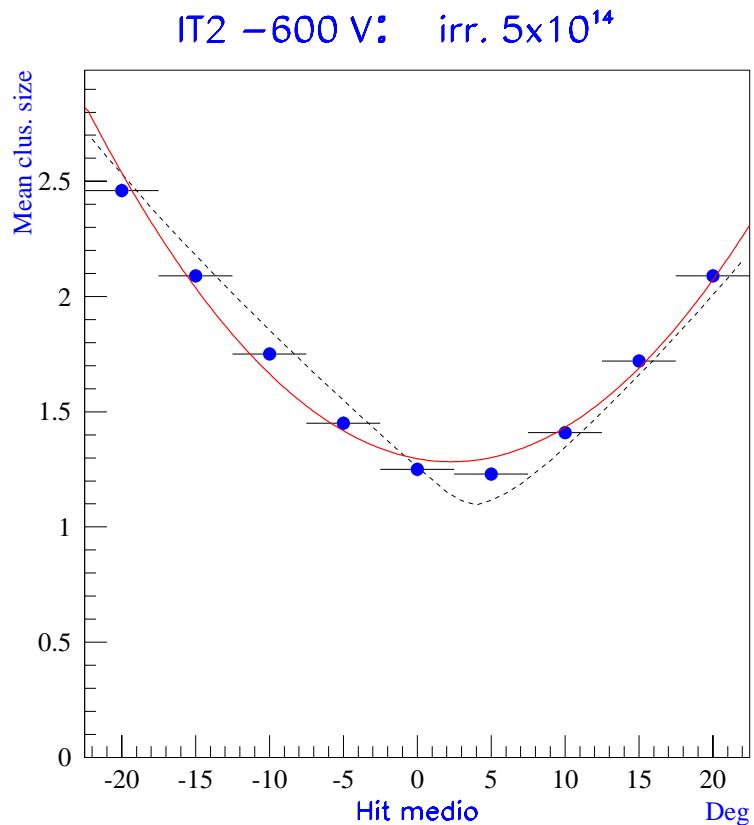


Measured value $\gamma_{\text{O}} = 3.1^{\circ} \pm 0.4^{\circ} \pm 0.6^{\circ}$

Predicted value $\gamma_{\text{O}} = 2.9^{\circ} \pm 0.2^{\circ}$



L O R E N T Z A N G L E F I T S



Measured value $\gamma_{\text{O}_\text{L}} = 2.6^\circ \pm 0.2^\circ \pm 0.3^\circ$

Predicted value $\gamma_{\text{O}_\text{L}} = 3.9^\circ \pm 0.2^\circ$

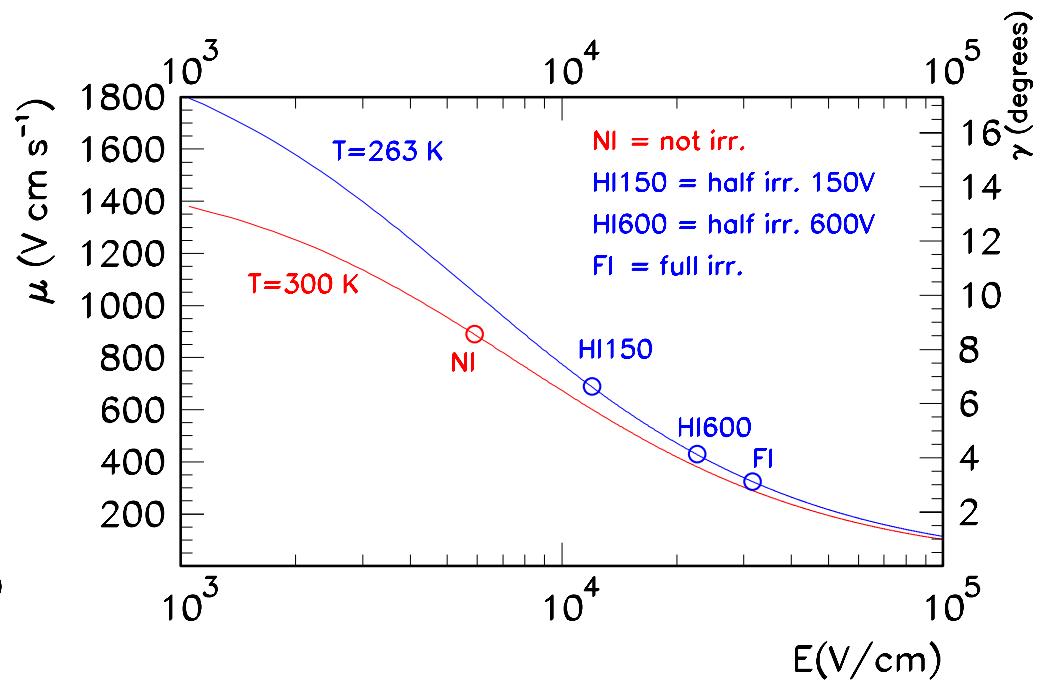
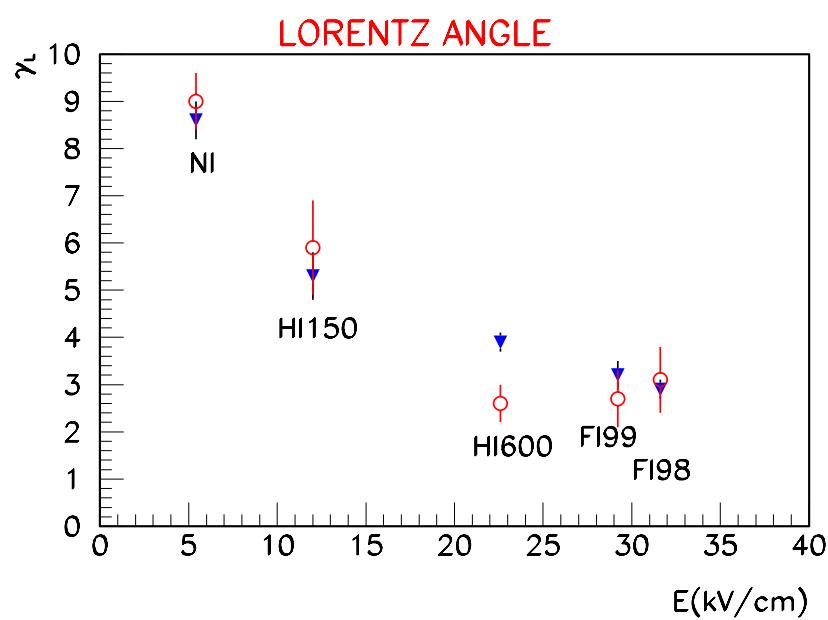
Measured value $\gamma_{\text{O}_\text{L}} = 5.9^\circ \pm 1.0^\circ \pm 0.3^\circ$

Predicted value $\gamma_{\text{O}_\text{L}} = 5.3^\circ \pm 0.5^\circ$



LORENTZ ANGLE RESULTS

Fluence	Bias Voltage V	Depletion depth [μm]	$\theta_L[^\circ]$ (Parabola)	$\theta_L[^\circ]$ (Model)
0	150	283 ± 6	$9.0 \pm 0.4 \pm 0.5$	9.0 ± 0.4
5×10^{14}	150	123 ± 11	$5.9 \pm 1.0 \pm 0.3$	5.7 ± 0.5
5×10^{14}	600	261 ± 8	$2.6 \pm 0.2 \pm 0.3$	4.1 ± 0.2
10^{15} ('98)	600	189 ± 12	$3.1 \pm 0.4 \pm 0.6$	3.0 ± 0.2
10^{15} ('99)	600	217 ± 13	$2.7 \pm 0.4 \pm 0.4$	3.4 ± 0.3



CONCLUSIONS

- Lorentz angle of ATLAS Pixel rad-hard sensors has been measured.
- The observed behavior is well explained by a model based on charge drift in silicon.
- The Lorentz angle (through the mobility) depends upon the Electric field inside sensors.
- At the operating conditions for ATLAS pixel sensor we expect a Lorentz angle of 13^0 at the beginning of data taking. After 10 years we expected a Lorentz angle of 4^0 .
- Depletion depth of sensors irradiated at two different fluences has been measured and characterized as a function of the operation voltage.

